## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hiroshi Nakayashiki Attorney Docket No.: YMUCP013

Application No.: 10/593,856 Examiner: H.Q. Pham

Filed: September 22, 2006 Group: 2886

Title: POSITION-DETECTING MECHANISM Confirmation No.: 5772

AND POSITION-DETECTING SENSOR

## CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on August 20, 2009.

Signed: /dn/ Deborah Neill

## SEPARATE LETTER TO EXAMINER REQUESTING DRAWING APPROVAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## Dear Sir:

In response to the Office Action mailed August 10, 2009, enclosed are replacement drawings for the above-identified patent application. If the Draftsman has any question concerning these drawings, he or she is respectfully requested to contact the undersigned.

Respectfully submitted,
Weaver Austin Villeneuve & Sampson LLP
/kn/

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